

## Amendments

### In the specification.

On page 1, under "Related Applications" please delete the section and replace with the following new text.

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#### **Related Applications**

This application claims priority under 35 U.S.C. § 119(e) from co-pending application serial number 60/298,878 filed June 19, 2001 and entitled "Advanced Process Control for Semiconductor Manufacturing Process."

This application claims priority under 35 U.S.C. § 119(e) from co-pending application serial number 60/305,782, filed July 16, 2001 and entitled "Feedforward and Feedback Control for Conditioning of Chemical Mechanical Polishing Pad."

This application claims priority under 35 U.S.C. § 119(e) from co-pending application serial number 60/318,741, filed September 12, 2001 and entitled "Feedforward and Feedback Control for Conditioning of Chemical Mechanical Polishing Pad."

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